

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:)
 NISHIMOTO et al) Group Art Unit: 2814
 Serial No.: 08/897,839) Examiner: K. Eaton
 Filed: July 21, 1997) VIA FACSIMILE
 For: STRESS-ADJUSTED INSULATING) 703 308 7722
 FILM FORMING METHOD,)
 SEMICONDUCTOR DEVICE AND)
 METHOD OF MANUFACTURING THE)
 SAME)

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 2.3

FAX COPY RECEIVED
 MAY 23 2000
 TECHNOLOGY CENTER 2000

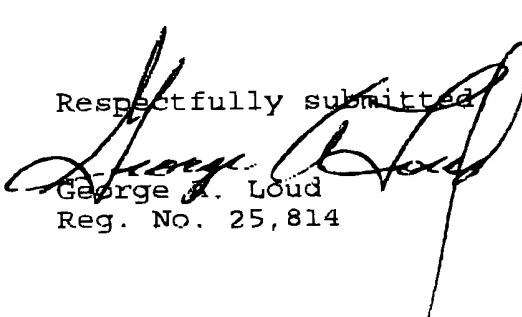
Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of February 3, 2000, initially set to expire May 3, 2000, be extended one month up to and including June 3, 2000. Please charge the requisite \$110.00 fee for the requested extension to our deposit account number 12-2174.

Any additional fees may also be charged to our Deposit Account No. 12-2174.

Respectfully submitted


 George A. Loud
 Reg. No. 25,814

05/24/2000 AFORD 00000001 122174 08897839
 01 FC:115 Pated: May 23, 2000
 110.00 CH

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